

7 th Semester	RBT7D002	Micro-fluidics	L-T-P 3-0-0	3 Credits
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Module I:**(10 Hours)**

1. **Introduction:** Origin, Definition, Benefits, Challenges, Commercial activities, Physics of miniaturization, Scaling laws.
2. **Micro-scale fluid mechanics:** Intermolecular forces, States of matter, Continuum assumption, Governing equations, Constitutive relations. Gas and liquid flows, Boundary conditions, Slip theory, Transition to turbulence, Low Re flows, Entrance effects. Exact solutions, Couette flow, Poiseuille flow, Stokes drag on a sphere, Time-dependent flows, Two-phase flows, Thermal transfer in microchannels. Hydraulic resistance and Circuit analysis, Straight channel of different cross-sections, Channels in series and parallel.

Module II:**(10 Hours)**

1. **Capillary flows:** Surface tension and interfacial energy, Young-Laplace equation, Contact angle, Capillary length and capillary rise, Interfacial boundary conditions, Marangoni effect.
2. **Electrokinetics:** Electrohydrodynamics fundamentals. Electro-osmosis, Debye layer, Thin EDL limit, Ideal electroosmotic flow, Ideal EOF with back pressure, Cascade electroosmotic micropump, EOF of power-law fluids. Electrophoresis of particles, Electrophoretic mobility, Electrophoretic velocity dependence on particle size. Dielectrophoresis, Induced polarization and DEP, Point dipole in a dielectric fluid, DEP force on a dielectric sphere, DEP particle trapping, AC DEP force on a dielectric sphere. Electro-capillary effects, Continuous electro-wetting, Direct electro-wetting, Electro-wetting on dielectric.

Module III:**(12 Hours)**

1. **Microfabrication techniques:** Materials, Clean room, Silicon crystallography, Miller indices. Oxidation, photolithography- mask, spin coating, exposure and development, Etching, Bulk and Surface micromachining, Wafer bonding. Polymer microfabrication, PMMA/COC/PDMS substrates, micromolding, hot embossing, fluidic interconnections.
2. **Microfluidics components:** Micropumps, Check-valve pumps, Valve-less pumps, Peristaltic pumps, Rotary pumps, Centrifugal pumps, Ultrasonic pump, EHD pump, MHD pumps. Microvalves, Pneumatic valves, Thermopneumatic valves, Thermomechanical valves, Piezoelectric valves, Electrostatic valves, Electromagnetic valves, Capillary force valves. Microflow sensors, Differential pressure flow sensors, Drag force flow sensors, Lift force flow sensors, Coriolis flow sensors, Thermal flow sensors. Micromixers, Physics of mixing, Pe-Re diagram of micromixers, Parallel lamination, Sequential lamination, Taylor-Aris dispersion.

Module IV:**(6 Hours)**

1. **Microfluidics components:** Droplet generators, Kinetics of a droplet, Dynamics of a droplet, In-channel dispensers, T-junction and Cross-junction, Droplet formation, breakup and transport. Microparticle separator, principles of separation and sorting of microparticles, design and applications. Microreactors, Design considerations, Liquid-phase reactors, PCR, Design consideration for PCR reactors.
2. **Applications of microfluidics:** Drug delivery, Diagnostics, Bio-sensing.

Books:

- [1] Nguyen, N. T., Wereley, S. T., Fundamentals and applications of Microfluidics, Artech house Inc., 2002
- [2] Bruus, H., Theoretical Microfluidics, Oxford University Press Inc., 2008
- [3] Colin, S., Microfluidics, John Wiley & Sons, 2009
- [4] Kirby, B.J., Micro- and Nanoscale Fluid Mechanics: Transport in Microfluidic Devices, Cambridge University Press, 2010